

ECLA**EUROPEAN CLASSIFICATION****G01L**

MEASURING FORCE, STRESS, TORQUE, WORK, MECHANICAL POWER, MECHANICAL EFFICIENCY, OR FLUID PRESSURE (sensing pressure changes for compensating measurements of other variables or compensating readings of instruments for variations in pressure G01D or other relevant subclasses for the variable measured; weighing G01G; converting a pattern of forces into electrical signals [G06K11/00](#))

Note

Attention is drawn to the Notes following the title of class G01.

G01L1/00

Measuring force or stress in general (measuring force due to impact [G01L5/00](#); measuring deformation of bodies as a result of stress by using gauges [G01B](#))

G01L1/00B

- . [N: by electrical means and not provided for in [G01L1/06](#) - [G01L1/22](#)]

G01L1/02

- . by hydraulic or pneumatic means

G01L1/04

- . by measuring elastic deformation of gauges, e.g. of springs

G01L1/04B

- . . [N: of helical springs]

G01L1/04C

- . . [N: of leaf springs]

G01L1/04D

- . . [N: of spiral springs]

G01L1/04E

- . . [N: of torsionally deformable elements]

G01L1/06

- . by measuring the permanent deformation of gauges, e.g. of compressed bodies

G01L1/08

- . by the use of counterbalancing forces [N: (automatic balancing arrangements for measuring electric variables in which a force or torque representing the measured value is balanced by a force or torque representing the reference value [G01R17/08](#))]

G01L1/08B

- . . [N: using hydraulic or pneumatic counterbalancing forces]

G01L1/08C

- . . [N: using electrostatic or electromagnetic counterbalancing forces]

G01L1/10

- . by measuring variations of frequency of stressed vibrating elements, e.g. of stressed strings (using resistance strain gauges [G01L1/22](#)) [N: using piezo-resistive vibrators [G01L1/18B](#)]

G01L1/10A

- . . [N: optical excitation or measuring of vibrations]

G01L1/10B

- . . [N: Constructional details]

G01L1/12

- . by measuring variations in the magnetic properties of materials resulting from the application of stress

G01L1/12A

- . . [N: by using permanent magnets] [N1107]

G01L1/12B

- . . [N: by using magnetostrictive means (magnetostrictive devices in general [H01L41/12](#); magnetostrictive sensors [H01L41/12B](#))] [N1107]

G01L1/12C

- . . [N: by using inductive means ([G01L12/12A](#), [G01L1/12B](#) take precedence)] [N1107]

G01L1/14

- . by measuring variations in capacitance or inductance of electrical elements, e.g. by measuring variations of frequency of electrical oscillators

- G01L1/14A . . [N: using capacitors]
- G01L1/14A2 . . . [N: with associated circuitry ([G01L1/14A4](#) and [G01L1/14A6](#) take precedence)]
- G01L1/14A4 . . . [N: for measuring force distributions, e.g. using force arrays ([G01L1/14A6](#) takes precedence)]
- G01L1/14A6 . . . [N: using semiconductive material, e.g. silicon]

- G01L1/16 . using properties of piezo-electric devices
- G01L1/16B . . [N: using piezo-electric resonators]
- G01L1/16B2 . . . [N: with acoustic surface waves]
- G01L1/16B4 . . . [N: optical excitation or measuring of vibrations]

- G01L1/18 . using properties of piezo-resistive materials, i.e. materials of which the ohmic resistance varies according to changes in magnitude or direction of force applied to the material ([resistance strain gauges for measuring linear expansion or contraction G01B](#))
- G01L1/18B . . [N: by measuring variations of frequency of vibrating piezo-resistive material]
- G01L1/18B4 . . . [N: optical excitation or measuring of vibrations]

- G01L1/20 . by measuring variations in ohmic resistance of solid materials or of electrically-conductive fluids ([of piezo-resistive materials G01L1/18](#)); by making use of electro-kinetic cells, i.e. liquid-containing cells wherein an electrical potential is produced or varied upon the application of stress
- G01L1/20B . . [N: using distributed sensing elements] [N9604]
- G01L1/22 . . using resistance strain gauges ([resistance strain gauges for measuring linear expansion or contraction G01B](#))
- G01L1/22B . . . [N: Special supports with preselected places to mount the resistance strain gauges; Mounting of supports]
- G01L1/22B2 [N: particularly adapted to unbounded-wire-type strain gauges]
- G01L1/22B7 [N: the supports being of the column type, e.g. cylindric, adapted for measuring a force along a single direction]
- G01L1/22B7B [N: the direction being perpendicular to the central axis]
- G01L1/22B8 [N: the supports being disc- or ring-shaped, adapted for measuring a force along a single direction]
- G01L1/22B8B [N: the direction being perpendicular to the central axis]
- G01L1/22B9 [N: the supports being parallelogram-shaped]
- G01L1/22C . . . [N: Measuring circuits therefor]
- G01L1/22C2 [N: involving digital counting]
- G01L1/22C4 [N: involving simple electrical bridges]
- G01L1/22D . . . [N: Arrangements for correcting or for compensating unwanted effects]
- G01L1/22D2 [N: for non linearity]
- G01L1/22D4 [N: for temperature variations]
- G01L1/22E . . . [N: constructional details of the strain gauges ([adjustable resistors H01C10/00](#))]
- G01L1/22E2 [N: of the semi-conductor type ([semi-conductor devices controllable by variations of applied mechanical force H01L29/84](#))]

- G01L1/24 . by measuring variations of optical properties of material when it is stressed, e.g. by photoelastic stress analysis [N: using infra-red, visible light, ultra-violet]
- G01L1/24A . . [N: by photoelastic stress analysis]

- G01L1/24B . . [N: the material being an optical fibre]
- G01L1/24B2 . . . [N: using means for applying force perpendicular to the fibre axis] [N0003]
- G01L1/24B2B [N: using micro-bending] [N0003]
- G01L1/24B4 . . . [N: using integrated gratings, e.g. Bragg gratings] [N0003]
- G01L1/24D . . [N: using distributed sensing elements, e.g. microcapsules (along a single optical fibre [G01L1/24B](#))] [N9502] [C9510]
- G01L1/24F . . [N: using infra-red ([G01L1/24A](#), [G01L1/24B](#) take precedence)]
- G01L1/25 . using wave or particle radiation, e.g. X-rays, [N: microwaves], neutrons ([G01L1/24](#) takes precedence)
- G01L1/25B . . [N: using acoustic waves, or acoustic emission ([G01L1/10](#) and [G01L1/16](#) take precedence)]
- G01L1/26 . Auxiliary measures taken, or devices used, in connection with the measurement of force, e.g. for preventing influence of transverse components of force, for preventing overload

G01L3/00 Measuring torque, work, mechanical power, or mechanical efficiency in general

- G01L3/02 . Rotary-transmission dynamometers
- G01L3/04 . . wherein the torque-transmitting element comprises a torsionally-flexible shaft
- G01L3/04A . . . [N: by measuring variations of frequency of stressed vibrating elements]
- G01L3/06 . . . involving mechanical means for indicating
- G01L3/08 . . . involving optical means for indicating
- G01L3/10 . . . involving electrical or magnetic means for indicating
- G01L3/10A [N: involving magnetic or electromagnetic means]
- G01L3/10A2 [N: involving magnetostictive means (magnetostrictive devices in general [H01L41/12](#); magnetostrictive sensors [H01L41/12B](#))] [C1107]
- G01L3/10A2M [N: Details about the magnetic material used] [N1107]
- G01L3/10A4 [N: involving permanent magnets] [N1107]
- G01L3/10A6 [N: involving inductive means ([G01L3/10A2](#), [G01L3/10A4](#) take precedence)] [N1107]
- G01L3/10B [N: involving electrostatic means]
- G01L3/10C [N: involving potentiometric means]
- G01L3/10D [N: involving resistance strain gauges]
- G01L3/10E [N: involving measuring phase difference of two signals or pulse trains]
- G01L3/12 involving photoelectric means
- G01L3/14 . . wherein the torque-transmitting element is other than a torsionally-flexible shaft
- G01L3/14A . . . [N: involving springs]
- G01L3/14A2 [N: using mechanical or hydraulic transducers] [M1204]
- G01L3/14A4 [N: using optical transducers] [M1204]
- G01L3/14A6 [N: using electrical transducers] [M1204]
- G01L3/14A6A [N: involving magnetic or electromagnetic means]
- G01L3/14A6B [N: involving electrostatic means]
- G01L3/14A6C [N: involving potentiometric means]

- G01L3/14A6D [N: involving resistance strain gauges]
- G01L3/14B [N: involving screws and nuts, screw-gears or cams]
- G01L3/14B2 [N: using planet wheels or conical gears]
- G01L3/14C [N: involving hinged levers]
- G01L3/14D [N: involving fluidic means]
- G01L3/14E [N: involving electric couplings]

- G01L3/16 Rotary-absorption dynamometers, e.g. of brake type
- G01L3/18 mechanically actuated
- G01L3/20 fluid actuated [N: fluid actuated brakes in general [F16D57/00](#)]
- G01L3/20A [N: of the air brake type (air actuated brakes in general [F16D57/00](#))]
- G01L3/22 electrically or magnetically actuated [N: electrical or magnetic brakes in general [H02K49/00](#)]

- G01L3/24 Devices for determining the value of power, e.g. by measuring and simultaneously multiplying the values of torque and revolution per unit of time, by multiplying the values of tractive or propulsive force and velocity ([measuring velocity per se G01P](#))
- G01L3/24B [N: by measuring and simultaneously multiplying torque and velocity]
- G01L3/24C [N: by measuring and simultaneously multiplying pressure and velocity]
- G01L3/24D [N: by measuring and simultaneously multiplying tractive or propulsive force and velocity]

- G01L3/26 Devices for measuring efficiency, i.e. the ratio of power output to power input

- G01L5/00** **Apparatus for, or methods of, measuring force, e.g. due to impact, work, mechanical power, or torque, adapted for special purposes** ([measuring pressure of a fluent medium G01L7/00 to G01L21/00](#); [measuring rapid changes of pressure in gas, steam or liquid G01L23/00](#))

- G01L5/00B [N: Force transducers adapted for mounting in a bore of the force receiving structure ([G01L5/00C](#) takes precedence)]
- G01L5/00C [N: Force sensors associated with a bearing (testing of bearings [G01M13/04](#))]
- G01L5/00C2 [N: by using capacitive sensors] [N1107]
- G01L5/00C4 [N: by using strain gages, piezo-electric, piezo-resistive or other ohmic-resistance based sensors] [N1107] [M1207]
- G01L5/00C6 [N: by using magnetic sensors] [N1107]

- G01L5/00D [N: Force sensors associated with force applying means ([G01L5/00H](#), [G01L5/00K](#), [G01L5/00M](#) take precedence)]
- G01L5/00D2 [N: applying a pulling force]
- G01L5/00D4 [N: applying a pushing force]
- G01L5/00D6 [N: applying a torque]

- G01L5/00G [N: measuring forces due to residual stresses]

- G01L5/00H [N: measuring forces due to impact ([G01L5/00M](#), [G01L5/14](#) take precedence; impact testing of structures [G01M7/08](#); impact testing of material [G01N3/00](#))]

- G01L5/00K . [N: measuring forces due to spring-shaped elements]
- G01L5/00M . [N: Force sensors associated with industrial machines or actuators (for the specific machine or actuator involved see relevant class, e.g. [F01](#), [F04](#), [F16](#), [B66](#), [E21](#))]
- G01L5/00M2 . . [N: Calibration arrangements (calibration of force sensors in general [G01L25/00](#))]
- G01L5/00M4 . . [N: Specific indicating arrangements, e.g. of overload]
- G01L5/00M8 . . [N: Force sensors associated with manufacturing machines ([G01L5/00M2](#), [G01L5/00M4](#) and [B23Q17/09](#) take precedence; for the specific machine or operation involved see relevant class, e.g. [B21](#) to [B42](#))]
- G01L5/00M8B . . . [N: Force sensors integrated in an article or a dummy workpiece]
- G01L5/00M8C . . . [N: Force sensors adapted for insertion between cooperating machine elements, e.g. for measuring the nip force between rollers]
- G01L5/00M8D . . . [N: Force sensors associated with material gripping devices (manipulators in general [G01L5/22](#))]
- G01L5/00N . [N: measuring work or mechanical power]
- G01L5/03 . for measuring release force of ski safety bindings
- G01L5/04 . for measuring tension in ropes, cables, wires, threads, belts, bands or like flexible members [N: (specially adapted for the strings of tennis rackets [A63B51/00M](#); [G01L5/00B](#) takes precedence)]
- G01L5/04B . . [N: by measuring vibrational characteristics of the flexible member]
- G01L5/04C . . [N: for measuring the tension across the width of a band-shaped flexible member (measuring flatness [G01B](#); metal rolling in general [B21B](#))]
- G01L5/04D . . [N: Specific indicating or recording arrangements, e.g. for remote indication, for indicating overload or underload]
- G01L5/06 . . using mechanical means [N: ([G01L5/04B](#), [G01L5/04C](#) take precedence)]
- G01L5/08 . . using fluid means [N: ([G01L5/04B](#), [G01L5/04C](#) take precedence)]
- G01L5/10 . . using electrical means [N: ([G01L5/04B](#), [G01L5/04C](#) take precedence)]
- G01L5/10B . . . [N: in which the sensor is inserted into the member] [[C0409](#)]
- G01L5/10C . . . [N: in which the sensor is located at a non-interrupted part of the member] [[N0406](#)] [[C0409](#)]
- G01L5/10D . . . [N: in which the sensor is fixed at one end of the member] [[N0406](#)] [[C0409](#)]
- G01L5/10E . . . [N: using electro-optical means]
- G01L5/10F . . . [N: by measuring a reaction force applied on a cantilever beam] [[N1107](#)]
- G01L5/10G . . . [N: by measuring a reaction force applied on an element disposed between two supports, i.e. on a plurality of rollers or gliders] [[N1107](#)]
- G01L5/10H . . . [N: by measuring a reaction force applied on a single support or glider] [[N1107](#)]
- G01L5/12 . for measuring axial thrust in a rotary shaft, e.g. of propulsion plants
- G01L5/13 . for measuring the tractive or propulsive power of vehicles
- G01L5/13B . . [N: for measuring thrust of propulsive devices, e.g. of propellers (aeroplanes [B64C](#); marine propulsion [B63H](#); jet-engines [F02K](#))]
- G01L5/13D . . [N: Force sensors associated with a vehicle traction coupling (vehicle connections [B60D](#); control of vehicle brakes [B60T](#))]
- G01L5/14 . for measuring the force of explosions; for measuring the energy of projectiles

- G01L5/16 . for measuring several components of force
- G01L5/16B . . [N: using variations in ohmic resistance]
- G01L5/16B2 . . . [N: of piezoresistors]
- G01L5/16B4 . . . [N: of potentiometers]
- G01L5/16C . . [N: using variations in inductance]
- G01L5/16D . . [N: using variations in capacitance]
- G01L5/16E . . [N: using photoelectric means]
- G01L5/16F . . [N: using piezo-electric means]
- G01L5/16G . . [N: using counterbalancing forces]

- G01L5/18 . for measuring ratios of force

- G01L5/20 . for measuring wheel side-thrust (in balancing G01M [N: 47B28])

- G01L5/22 . for measuring the force applied to control members, e.g. control members of vehicles, triggers
- G01L5/22B . . [N: to steering wheels, e.g. for power assisted steering]
- G01L5/22C . . [N: to joystick controls]
- G01L5/22D . . [N: to foot actuated controls, e.g. brake pedals]
- G01L5/22K . . [N: to manipulators, e.g. the force due to gripping]
- G01L5/22K2 . . . [N: using tactile array force sensors]

- G01L5/24 . for determining value of torque or twisting moment for tightening a nut or other member which is similarly stressed (arrangements in wrenches or screwdrivers B25B23/14; [N: scremed connections specially modified to indicate the attainment of a particular tensile load F16B31/02]) [C9602]
- G01L5/24B . . [N: using washers]
- G01L5/24D . . [N: using acoustic waves (for force in general G01L1/25B)]

- G01L5/26 . for determining the characteristic of torque in relation to revolutions per unit of time

- G01L5/28 . for testing brakes
- G01L5/28B . . [N: the vehicle wheels cooperating with rotatable rolls]
- G01L5/28C . . [N: Measuring braking-time or braking distance]
- G01L5/28D . . [N: Measuring deceleration (deceleration in general G01P)]
- G01L5/28E . . [N: Measuring the force necessary to rotate a braked wheel]

Guide heading: **Measuring fluid pressure**

G01L7/00 **Measuring the steady or quasi-steady pressure of a fluid or a fluent solid material by mechanical or fluid pressure-sensitive elements** [N: [G01L11/00E](#) takes precedence] (transmitting or indicating the displacement of mechanical pressure-sensitive elements by electric, [N: e.g. photoelectric] or magnetic means [G01L9/00](#); measuring differences of two or more pressure values [G01L13/00](#); measuring two or more pressure values simultaneously [G01L15/00](#); measuring tyre pressure or the pressure of other inflated bodies [G01L17/00](#); vacuum gauges [G01L21/00](#); hollow bodies deformable or displaceable under internal pressure, per se [G12B1/04](#); [N: pressure sensitive switches using Bourbon gauges [H01H9/00](#); pressure sensitive fluidum level or volume measuring

devices [G01F17/00](#); [G01F23/14](#), [G01F23/16](#) pressure sensitive depth meters [G01C13/00B](#); aircraft altitude meters [G01C5/00A](#))]

- G01L7/02
 - in the form of elastically-deformable gauges
- G01L7/02A
 - • [N: constructional details e.g. mounting of elastically-deformable gauges ([G01L7/04A](#), [G01L7/06A](#), [G01L7/08A](#), [G01L7/10A](#), [G01L7/16A](#), [G01L7/18A](#) take precedence over [G01L7/02A](#))]
- G01L7/02B
 - • [N: with mechanical transmitting or indicating means ([G01L7/04B](#), [G01L7/06B](#), [G01L7/08B](#), [G01L7/10B](#), [G01L7/16B](#), [G01L7/18B](#) take precedence over [G01L7/02B](#))]
- G01L7/02C
 - • [N: with optical transmitting or indicating means ([G01L7/04C](#), [G01L7/06C](#), [G01L7/08C](#), [G01L7/10C](#), [G01L7/18C](#) take precedence over [G01L7/02C](#))]
- G01L7/02D
 - • [N: correcting or regulating means ([G01L7/04E](#), [G01L7/06E](#), [G01L7/08D](#), [G01L7/10D](#) take precedence over [G01L7/02D](#))]
- G01L7/04
 - • in the form of flexible, deformable tubes, e.g. Bourdon gauges
- G01L7/04A
 - • • [N: Construction or mounting of deformable tubes]
- G01L7/04B
 - • • [N: with mechanical transmitting or indicating means]
- G01L7/04C
 - • • [N: with optical transmitting or indicating means]
- G01L7/04D
 - • • [N: with exhausted tubes]
- G01L7/04E
 - • • [N: correcting or regulating means for flexible, deformable tubes]
- G01L7/06
 - • of the bellows type
- G01L7/06A
 - • • [N: construction or mounting of bellows]
- G01L7/06B
 - • • [N: with mechanical transmitting or indicating means]
- G01L7/06C
 - • • [N: with optical transmitting or indicating means]
- G01L7/06D
 - • • [N: with exhausted bellows]
- G01L7/06E
 - • • [N: correcting or regulating means for bellows]
- G01L7/08
 - • of the flexible-diaphragm type
- G01L7/08A
 - • • [N: construction or mounting of diaphragms (of semiconductive diaphragms [G01L9/00D1](#))]
- G01L7/08B
 - • • [N: with mechanical transmitting or indicating means]
- G01L7/08C
 - • • [N: with optical transmitting or indicating means]
- G01L7/08D
 - • • [N: correcting or regulating means for flexible diaphragms]
- G01L7/10
 - • of the capsule type
- G01L7/10A
 - • • [N: construction or mounting of capsules]
- G01L7/10B
 - • • [N: with mechanical transmitting or indicating means]
- G01L7/10C
 - • • [N: with optical transmitting or indicating means]
- G01L7/10D
 - • • [N: correcting or regulating means for capsules]
- G01L7/12
 - • • with exhausted chamber; Aneroid barometers
- G01L7/14
 - • • • with zero-setting means
- G01L7/16
 - in the form of pistons
- G01L7/16A
 - • [N: construction or mounting of pistons]
- G01L7/16B
 - • [N: with mechanical transmitting or indicating means]
- G01L7/18
 - using liquid as the pressure-sensitive medium, e.g. liquid-column gauges

- G01L7/18A . . [N: constructional details, e.g. mounting]
- G01L7/18B . . [N: with mechanical transmitting or indicating means]
- G01L7/18C . . [N: with optical transmitting or indicating means]
- G01L7/20 . . involving a closed chamber above the liquid level, the chamber being exhausted or housing low-pressure gas; liquid barometers
- G01L7/22 . . involving floats, e.g. floating bells
- G01L7/24 . . involving balances in the form of rings partly filled with liquid

G01L9/00 **Measuring steady or quasi-steady pressure of a fluid or a fluent solid material by electric or magnetic pressure-sensitive elements [N: ([G01L11/00E](#) takes precedence)]; Transmitting or indicating the displacement of mechanical pressure-sensitive elements, used to measure the steady or quasi-steady pressure of a fluid or fluent solid material by electric or magnetic means (measuring differences of two or more pressure values [G01L13/00](#); measuring two or more pressure values simultaneously [G01L15/00](#); vacuum gauges [G01L21/00](#); transferring the output of the sensing member to the indicating or recording part in general [G01D5/00](#))**

- G01L9/00A . [N: Transmitting or indicating the displacement of elastically deformable gauges by electric, electro-mechanical, magnetic or electro-magnetic means ([G01L9/00B](#), [G01L9/00C](#), [G01L9/00E](#), [G01L9/00F](#), [G01L9/00G](#) take precedence)]
- G01L9/00A2 . . [N: using variations in ohmic resistance ([G01L9/00D2](#) takes precedence)]
- G01L9/00A4 . . [N: using variations in inductance ([G01L9/00D4](#) takes precedence)]
- G01L9/00A6 . . [N: using variations in capacitance ([G01L9/00D6](#) takes precedence)]
- G01L9/00A8 . . [N: using photoelectric means ([G01L9/00D8](#) takes precedence)]
- G01L9/00A10 . . [N: using vibrations]
- G01L9/00A10A . . . [N: of an element not provided for in the following subgroups of [G01L9/00A10](#) (not used)]
 - G01L9/00A10A2 [N: Optical excitation or measuring]
 - G01L9/00A10B [N: of a string]
 - G01L9/00A10B2 [N: Optical excitation or measuring of vibrations]
 - G01L9/00A10C [N: of a diaphragm]
 - G01L9/00A10C2 [N: Optical excitation or measuring]
 - G01L9/00A10D [N: of a semiconductive element]
 - G01L9/00A10D2 [N: Optical excitation or measuring]
 - G01L9/00A10E [N: of a piezoelectric element]
 - G01L9/00A10E2 [N: Optical excitation or measuring]
 - G01L9/00A10E4 [N: with acoustic surface waves]
- G01L9/00B . [N: Transmitting or indicating the displacement of flexible, deformable tubes by electric, electro-mechanical, magnetic or electro-magnetic means ([G01L9/00A10](#) takes precedence; pressure sensitive flexible, deformable tubes in general 7/04)]
- G01L9/00B2 . . [N: using variations in ohmic resistance]
- G01L9/00B4 . . [N: using variations in inductance]
- G01L9/00B6 . . [N: using variations in capacitance]
- G01L9/00B8 . . [N: using photoelectric means]
- G01L9/00C . [N: Transmitting or indicating the displacement of bellows by electric, electro-mechanical, magnetic, or electro-magnetic means ([G01L9/00A10](#) takes precedence)]

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| | precedence; pressure sensitive bellows in general G01L7/06)] |
| G01L9/00C2 | . . [N: using variations in ohmic resistance] |
| G01L9/00C4 | . . [N: using variations in inductance] |
| G01L9/00C6 | . . [N: using variations in capacitance] |
| G01L9/00C8 | . . [N: using photoelectric means] |
| G01L9/00D | . [N: Transmitting or indicating the displacement of flexible diaphragms (pressure sensitive flexible diaphragms in general G01L7/08)] |
| G01L9/00D1 | . . [N: Constructional details associated with semiconductive diaphragm sensors, e.g. etching, or constructional details of non-semiconductive diaphragms (details about the integration or bonding of piezoresistor in or on the diaphragm G01L9/00D2B and G01L9/00D2C respectively)] [N1204] |
| G01L9/00D1B | . . . [N: Constructional details of non-semiconductive diaphragms] [N1204] |
| G01L9/00D1C | . . . [N: Diaphragm associated with a buried cavity] [N1204] |
| G01L9/00D1D | . . . [N: Diaphragm with non uniform thickness, e.g. with grooves, bosses or continuously varying thickness] [N1204] |
| G01L9/00D1E | . . . [N: Details about the mounting of the diaphragm to its support or about the diaphragm edges, e.g. notches, round shapes for stress relief] [N1204] |
| G01L9/00D1F | . . . [N: Non square semiconductive diaphragm] [N1204] |
| G01L9/00D2 | . . [N: using variations in ohmic resistance] |
| G01L9/00D2B | . . . [N: of piezoresistive elements (circuits therefor G01L9/06)] |
| G01L9/00D2B2 | [N: integral with a semiconducting diaphragm] |
| G01L9/00D2B4 | [N: bonded on a diaphragm] |
| G01L9/00D2C | . . . [N: of potentiometers] |
| G01L9/00D2D | . . . [N: of pressure sensitive conductive solid or liquid material, e.g. carbon granules] |
| G01L9/00D2E | . . . [N: of metallic strain gauges fixed to an element other than the pressure transmitting diaphragm] |
| G01L9/00D2E2 | [N: using unbounded-wire-type strain gauges] |
| G01L9/00D2E6 | [N: the element and the diaphragm being in intimate contact] |
| G01L9/00D4 | . . [N: using variations in inductance] |
| G01L9/00D6 | . . [N: using variations in capacitance] |
| G01L9/00D6B | . . . [N: using a semiconductive diaphragm] |
| G01L9/00D6C | . . . [N: using a ceramic diaphragm, e.g. alumina, fused quartz, glass] |
| G01L9/00D8 | . . [N: using photoelectric means] |
| G01L9/00D8B | . . . [N: for measuring reflected light] |
| G01L9/00D8B2 | [N: with Fabry-Perot arrangements] |
| G01L9/00D10 | . . [N: using piezoelectric devices (piezoelectric resonators G01L9/00A10E ; surface acoustic waves G01L9/00A10E4)] |
| G01L9/00E | . [N: Transmitting or indicating the displacement of capsules by electric, electro-mechanical, magnetic, or electro-mechanical means (G01L9/00A10 takes precedence; pressure sensitive capsules in general G01L7/10)] |
| G01L9/00E2 | . . [N: using variations in ohmic resistance] |
| G01L9/00E4 | . . [N: using variations in inductance] |
| G01L9/00E6 | . . [N: using variations in capacitance] |

- G01L9/00E8 . . [N: using photoelectric means]
- G01L9/00F . [N: Transmitting or indicating the displacement of pistons by electrical, electro-mechanical, magnetic or electro-magnetic means ([G01L9/00A10](#) takes precedence; pressure sensitive pistons in general [G01L7/16](#))]
- G01L9/00G . [N: Transmitting or indicating the displacement of liquid mediums by electrical, electro-mechanical, magnetic or electro-magnetic means ([G01L9/00A10](#) takes precedence; pressure sensitive liquid mediums in general [G01L7/18](#))]
- G01L9/00G2 . . [N: using variations in ohmic resistance]
- G01L9/00G4 . . [N: using variations in inductance]
- G01L9/00G6 . . [N: using variations in capacitance]
- G01L9/00G8 . . [N: using photoelectric means]
- G01L9/00T . [N: using semiconductor body comprising at least one PN junction as detecting element]
- G01L9/02 . by making use of variation in ohmic resistance, e.g. of potentiometers, [N: , i.e. electric circuits therefor, e.g. bridges, amplifiers or signal conditioning] [C1107]
- G01L9/02T . . [N: with temperature compensating means (non electric temperature compensating means [G01L19/04](#))] [N1107]
- G01L9/04 . . of resistance-strain gauges
- G01L9/04T . . . [N: with electric temperature compensating means (non electric temperature compensating means [G01L19/04](#))] [N1107]
- G01L9/06 . . of piezo-resistive devices
- G01L9/06T . . . [N: with temperature compensating means (non electric temperature compensating means [G01L19/04](#))] [N1107]
- G01L9/08 . by making use of piezo-electric devices [N: , i.e. electric circuits therefor] [C1107]
- G01L9/08T . . [N: with temperature compensating means (non electric temperature compensating means [G01L19/04](#))] [N1107]
- G01L9/10 . by making use of variation in inductance [N: , i.e. electric circuits therefor] [C1107]
- G01L9/10T . . [N: with temperature compensating means (non electric temperature compensating means [G01L19/04](#))] [N1107]
- G01L9/12 . by making use of variation in capacitance [N: , i.e. electric circuits therefor] [C1107]
- G01L9/12T . . [N: with temperature compensating means (non electric temperature compensating means [G01L19/04](#))] [N1107]
- G01L9/14 . involving the displacement of magnets, e.g. electro-magnets
- G01L9/16 . by making use of variations in the magnetic properties of material resulting from the application of stress
- G01L9/18 . by making use of electrokinetic cells, i.e. liquid-containing cells wherein an electric potential is produced or varied upon the application of stress
- G01L11/00** **Measuring steady or quasi-steady pressure of a fluid or a fluent solid material by means not provided for in group [G01L7/00](#) or [G01L9/00](#)**

- G01L11/00D . [N: by thermal means e.g. hypsometer]
- G01L11/00E . [N: by the use of counterbalancing forces (measuring force by the use of counterbalancing forces [G01L1/08](#))]
- G01L11/00E2 . . [N: hydraulic or pneumatic counterbalancing forces]
- G01L11/00E4 . . [N: electrostatic or electromagnetic counterbalancing forces]
- G01L11/02 . by optical means
- G01L11/02B . . [N: using a pressure-sensitive optical fibre]
- G01L11/04 . by acoustic means
- G01L11/06 . . Ultrasonic means

G01L13/00 **Devices or apparatus for measuring differences of two or more pressure values**

- G01L13/02 . using elastically-deformable members or pistons as sensing elements
- G01L13/02A . . [N: using deformable tubes]
- G01L13/02B . . [N: using bellows]
- G01L13/02C . . [N: using diaphragms]
- G01L13/02C2 . . . [N: involving double diaphragm] [N1107]
- G01L13/02D . . [N: using capsules]
- G01L13/04 . using floats or liquids as sensing elements
- G01L13/06 . using electric or magnetic pressure-sensitive elements

G01L15/00 **Devices or apparatus for measuring two or more pressure values simultaneously**

G01L17/00 **Devices or apparatus for measuring tyre pressure or the pressure in other inflated bodies (specially adapted for mounting on vehicles or tyres [B60C23/00](#))**

- G01L17/00D . [N: using a sensor contacting the exterior surface, e.g. for measuring deformation]

G01L19/00 **Details of, or accessories for, apparatus for measuring steady or quasi-steady pressure of a fluent medium insofar as such details or accessories are not special to particular types of pressure gauges**

- G01L19/00B . [N: Fluidic connecting means] [N1204]
- G01L19/00B2 . . [N: using switching means] [N9506]
- G01L19/00B4 . . [N: for flowthrough systems having a flexible pressure transmitting element] [N0003]
- G01L19/00B6 . . [N: using a detachable interface or adapter between the process medium and the pressure gauge] [N1204]
- G01L19/00B8 . . [N: being part of the housing (other details about the housing G01L19/14)] [N1204]
- G01L19/00B10 . . [N: using isolation membranes (G01L13/02C2 and G01L19/06D4 take precedence)] [N1204]

- G01L19/00E . [N: Electrical connection means] [N1204]
- G01L19/00E2 . . [N: from the sensor to its support] [N1204]
- G01L19/00E2B . . . [N: using buried connections] [N1204]
- G01L19/00E4 . . [N: to the outside of the housing (other details about the housing see G01L19/14)] [N1204]

- G01L19/00S . [N: Pressure sensor associated with other sensors, e.g. for measuring acceleration or temperature (G01L9/02T, G01L9/04T, G01L9/06T, G01L9/08T, G01L9/10T, G01L9/12T, G01L19/02, G01L19/04 take precedence; measuring two or more variable G01D21/02; temperature sensors with pressure compensation G01K1/26)] [N1204]

- G01L19/02 . Arrangements for preventing, or for compensating for, effects of inclination or acceleration of the measuring device; Zero-setting means (for aneroid barometers [G01L7/14](#))

- G01L19/04 . Means for compensating for effects of changes of temperature [N: , i.e. other than electric compensation (electric compensation [G01L9/02T](#), [G01L9/04T](#), [G01L9/06T](#), [G01L9/08T](#), [G01L9/10T](#) or [G01L9/12T](#))] [C1107]

- G01L19/06 . Means for preventing overload or deleterious influence of the measured medium on the measuring device or vice versa
- G01L19/06B . . [N: Pressure pulsation damping arrangements] [N0405]
- G01L19/06C . . [N: Overload protection] [N1107]
- G01L19/06D . . [N: Protection against aggressive medium in general] [N1107]
- G01L19/06D2 . . . [N: using particle filters] [N1107]
- G01L19/06D4 . . . [N: using isolation membranes, specially adapted for protection (use of coupling membranes with a coupling fluid in general [G01L9/00D2E4](#), [G01L9/00D2F2](#))] [N1107]
- G01L19/06D6 . . . [N: against moisture or humidity] [N1107]
- G01L19/06E . . [N: Flame protection; Flame barriers] [N1107]
- G01L19/06F . . [N: Leakage or rupture protection or detection (detection of leakage per se [G01M3/00](#))] [N1107]
- G01L19/06G . . [N: Protection against excessive heat] [N1107]
- G01L19/06H . . [N: Protection against electromagnetic or electrostatic interferences] [N1204]

- G01L19/08 . Means for indicating or recording, e.g. for remote indication (indicating or recording in general [G01D](#))
- G01L19/08B . . [N: electrical]
- G01L19/08C . . [N: for remote indication]
- G01L19/10 . . mechanical
- G01L19/12 . . Alarms or signals

- G01L19/14 . [N: Housings (G01L19/00B, G01L19/00E4, G01L19/00S, G01L19/04, G801L19/06 take precedence)] [N1204]
- G01L19/14B . . [N: Monolithic housings, e.g. molded or one-piece housings] [N1204]
- G01L19/14C . . [N: Multiple part housings] [N1204]
- G01L19/14C2 . . . [N: Two part housings] [N1204]
- G01L19/14C4 . . . [N: with dismountable parts, e.g. for maintenance purposes or for ensuring

sterile conditions (for detachable interface or adapter between the process medium and the pressure gauge G01L19/00B6)] [\[N1204\]](#)

- G01L19/14D . . [N: with stress relieving means] [\[N1204\]](#)
- G01L19/14D2 . . . [N: using flexible element between the transducer and the support] [\[N1204\]](#)
- G01L19/14E . . [N: Details about the mounting of the sensor to support or covering means] [\[N1204\]](#)
- G01L19/14F . . [N: Details about the circuit board integration, e.g. integrated with the diaphragm surface or encapsulation] [\[N1204\]](#)
- G01L19/14G . . [N: of immersion sensor, e.g. where the sensor is immersed in the measuring medium or for in vivo measurements, e.g. by using catheter tips (catheter tips per se A61M25/00T; pressure measurements in the body A61B5/00)] [\[N1204\]](#)

- G01L19/16 . Dials; Mounting of dials

G01L21/00 Vacuum gauges

- G01L21/02 . having a compression chamber in which gas, whose pressure is to be measured, is compressed
- G01L21/04 . . wherein the chamber is closed by liquid; vacuum gauges of the McLeod type
- G01L21/06 . . . actuated by rotating or inverting the measuring device
- G01L21/08 . by measuring variations in the transmission of acoustic waves through the medium, the pressure of which is to be measured
- G01L21/10 . by measuring variations in the heat conductivity of the medium, the pressure of which is to be measured
- G01L21/12 . . measuring changes in electric resistance of measuring members, e.g. of filaments; Vacuum gauges of the Pirani type
- G01L21/14 . . using thermo-couples
- G01L21/16 . by measuring variation of frictional resistance of gases
- G01L21/18 . . using a pendulum
- G01L21/20 . . using members oscillating about a vertical axis
- G01L21/22 . . using resonance effects of a vibrating body; Vacuum gauges of the Klumb type
- G01L21/24 . . using rotating members; Vacuum gauges of the Langmuir type [\[N: Langmuir probes for plasma diagnostics H05H1/00A\]](#)
- G01L21/26 . by making use of radiometer action, i.e. of the pressure caused by the momentum of molecules passing from a hotter to a cooler member; Vacuum gauges of the Knudsen type
- G01L21/28 . . using torsional rotary measuring members
- G01L21/30 . by making use of ionisation effects [\(tubes therefor H01J41/02\)](#)
- G01L21/32 . . using electric discharge tubes with thermionic cathodes
- G01L21/34 . . using electric discharge tubes with cold cathodes
- G01L21/36 . . using radioactive substances

G01L23/00 Devices or apparatus for measuring or indicating or recording rapid changes, such as oscillations, in the pressure of steam, gas, or liquid; Indicators for determining work or energy of steam, internal-combustion, or other fluid-pressure engines from the condition of the working fluid

- G01L23/02 . mechanically indicating or recording and involving loaded or return springs
- G01L23/04 . involving means subjected to known counter-acting pressure
- G01L23/06 . Indicating or recording by optical means
- G01L23/08 . operated electrically [N: [G01L23/22](#) takes precedence]
- G01L23/08B . . [N: by measuring fluctuations of starter motor current or of battery voltage (battery testing arrangements [G01R31/36](#); testing of electrical installation on transport means [G01R31/00T](#); battery testing arrangements [G01R31/36](#))] [C9809]
- G01L23/10 . . by pressure-sensitive members of the piezo-electric type
- G01L23/12 . . by changing capacitance or inductance
- G01L23/12A . . . [N: by changing capacitance]
- G01L23/14 . . by electromagnetic elements
- G01L23/14A . . . [N: by magnetostrictive elements]
- G01L23/16 . . by photoelectric means
- G01L23/18 . . by resistance strain gauges
- G01L23/20 . combined with planimeters or integrators
- G01L23/22 . for detecting or indicating knocks in internal-combustion engines; Units comprising pressure-sensitive members combined with ignitors for firing internal-combustion engines
- G01L23/22B . . [N: for detecting or indicating knocks in internal combustion engines]
- G01L23/22B2 . . . [N: using piezoelectric devices]
- G01L23/22B4 . . . [N: using magnetic or magnetostrictive means]
- G01L23/22B6 . . . [N: circuit arrangements therefor] [N0107]
- G01L23/22B6F [N: using specific filtering] [N1107]
- G01L23/22B6S [N: using numerical analyses] [N1107]
- G01L23/24 . [N: specially adapted] for measuring pressure in inlet or exhaust ducts of internal-combustion engines
- G01L23/26 . Details or accessories
- G01L23/28 . . Cooling means
- G01L23/30 . . Means for indicating consecutively positions of pistons or cranks of internal-combustion engines in combination with pressure indicators
- G01L23/32 . . Apparatus specially adapted for recording pressure changes measured by indicators (apparatus for recording steady or quasi-steady pressure [G01L19/08](#); apparatus for recording measurement in general [G01D](#))
- G01L25/00** **Testing or calibrating of apparatus for measuring force, work, torque, mechanical power, or mechanical efficiency**
- G01L25/00C . [N: for measuring torque]
- G01L25/00D . [N: for measuring work or mechanical power or mechanical efficiency]

G01L27/00

Testing or calibrating of apparatus for measuring fluid pressure

G01L27/00C

- [N: Calibrating, i.e. establishing true relation between transducer output value and value to be measured, zeroing, linearising or span error determination (calibration of sensors per se [G01D18/00](#))] [N1107]

G01L27/00C2

- . [N: Apparatus for calibrating pressure sensors] [N1107]

G01L27/00D

- [N: Malfunction diagnosis, i.e. diagnosing a sensor defect (malfunction detection of sensor not measuring a specific variable per se [G01D3/08](#))] [N1107]

G01L27/02

- of indicators